

Form 1449 (Modified)

Information Disclosure
Statement By Applicant

(Use Several Sheets if Necessary)

Atty Docket No.	LAM1P128
Application No.:	09/440,794
Applicant	Bailey III et al.
Filing Date	November 15, 1999
Group	1765

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U.S. Patent Documents

Examiner Initial	No.	Patent No.	Date	Patentee	Class	Sub-class	Filing Date
MA	A.	5,810,932	09/1998	Ueda et al.			
	B.						
	C.						
	D.						
	E.						

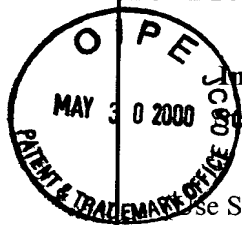
Foreign Patent or Published Foreign Patent Application

Examiner Initial		Document No.	Publication Date	Country or Patent Office	Class	Sub-Class	Translation	
							Yes	No
MA	F.	EP 0 821 397 A2	01/1998	EPO				
MA	G.	WO 99/50886	10/1999	PCT				
	H.							
	I.							
	J.							
	K.							

Other Documents

Examiner Initial	No.	Author, Title, Place (e.g. Journal) of Publication, Date
MA	L.	Japanese Application No. 04094953, filed March 1992, entitled "PLASMA DAMAGE REDUCTION AND PLASMA PROCESSOR," by Minegishi Kazushige, Patent Abstracts of Japan, Vol. 18, No. 33. ✓
MA	M.	Japanese Application No. 08255259, filed August 1996, entitled "SHALLOW MAGNETIC FIELD FOR IMPROVING PLASMA PROCESSING BY THE CIRCULATION OF ELECTRONS," by Michael Welch, Patent Abstracts of Japan, Vol. 1999, No. 7. ✓
	N.	
	O.	
	P.	
	Q.	
	R.	
	S.	
Examiner	Date Considered	
MA	9/03/01	

Examiner: Initial citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.



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U.S. Patent Documents

Examiner Initial	No.	Patent No.	Date	Patentee	Class	Sub-class	Filing Date
MAA	A.	4,948,458	08/1990	Ogle			
MAA	B.	4,990,229	02/1991	Campbell et al.			
MAA	C.	5,091,049	02/1992	Campbell et al.			
MAA	D.	5,122,251	06/1992	Campbell et al.			
MAA	E.	5,421,891	06/1995	Campbell et al.			
MAA	F.	5,429,070	07/1995	Campbell et al.			
MAA	G.	5,587,038	12/1996	Cecchi et al.			

Foreign Patent or Published Foreign Patent Application

Examiner Initial		Document No.	Publication Date	Country or Patent Office	Class	Sub-Class	Translation	
							Yes	No
MAA	H.	0 838 843 A2	04/1998	EPO				
	I.							
	J.							

Other Documents

Examiner Initial	No.	Author, Title, Place (e.g. Journal) of Publication, Date
	K.	
	L.	
	M.	
	N.	
	O.	
	P.	
	Q.	
	R.	
Examiner	Matthew C. Rubin	
	Date Considered	9/03/01

Examiner: Initial citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.